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- 1 -

Application No. 10/658,472

Docket No. 740756-2650

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hidekazu MIYAJI et al.

Serial No. 10/658,472

Filed: September 10, 2003

For: LASER APPARATUS, LASER IRRADIATION

METHOD, AND MANUFACTURING METHOD OF

SEMICONDUCTOR DEVICE

Examiner: Phillip Nguyen

Group Art Unit: 2828

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or being facsimile transmitted to the USPTO at 571-273-8300, on July 7, 2006.

Signature:

Name: Pamela L. Patrick

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initial a copy of this form be returned to the undersigned.

The Commissioner is authorized to charge the amount of \$180.00 to Deposit Account No. 19-2380 (740756-2650) in compliance with the provisions of 37 C.F.R. § 1.97(c)

07/11/2006 AWONDAF1 00000032 192380 10658472

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PAGE 1/15 * RCVD AT 7/7/2006 6:20:54 PM [Eastern Daylight Time] * SVR:USPTO-EFAX-3/9 * DNIS:2738300 * CSID:866 741 0075 * DURATION (mm-ss):04-52

us Patent Page 3/15 and 5/15

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- 2 -

Application No. 10/658,472,
Docket No. 740756-2650

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By:


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Substitute for form 1449A/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	10/658,472
		Filing Date	September 10, 2003
		First Named Inventor	Hideakazu MIYAJIRI et al.
		Art Unit	2828
		Examiner Name	Philip Nguyen
Sheet 1	of 1	Attorney Docket Number	740756-2650

U.S. PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		US-6,166,845	12/26/2000	Ito et al.	
		US-2004/0203248 A1	10/14/2004	Miyajiri et al.	
		US-			
		US-			
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		US-			
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³	Number ³ Kind Code ² (if known)			

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Hideaki KUSAMA, "EXCIMER LASER ANNEALING APPARATUS", Liquid Crystal Display Technology 2001, Liquid Crystal Display Manufacturing Technology Edition, pp. 138-141; July 1, 2001. (Japanese Article with Full Translation)	
Examiner Signature			Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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